



The 4M Association, IFMM and I2M2
proudly present the

Honorable Mention Paper Award

at the 6th World Congress on Micro and
Nano Manufacturing - WCMNM 2023

(Evanston, IL, USA, 18th - 21nd September 2023)

to

Tatsuya Funazuka, Syunsuke Horiuchi,
Kuniaki Dohda and Tomomi Shiratori

for their paper titled

“Effect of CoCrMo Die with Nanotexture
Applied on Micro-Extrudability of Micro
Backward Extrusion of AA6063”

4M Coordinator

IFMM President

I2M2 President